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APPLICANTS

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SC
** CONTINUING DATA *****

SC
** FOREIGN APPLICATIONS *****
JAPAN 2000-354471 11/21/2000

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| 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | | | |
| Verified and Acknowledged Examiner's Signature <i>12/23/04</i> | Initials <i>12/23/04</i> | | | |

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000513
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TITLE
Method and apparatus for correcting inclination of IC on semiconductor wafer

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|------------|---|---|
| FILING FEE | FEES: Authority has been given in Paper | <input type="checkbox"/> All Fees |
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